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OCT 14 2004

2623

Technology Center 2600

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Ryoichi MATSUOKA :  
Serial No. 09/903,600 : Group Art Unit - 2623  
Filed: July 12, 2001 : Examiner - Virginia Kibler  
For: WAFER PATTERN OBSERVATION :  
METHOD AND DEVICE : Docket No. S004-4331

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MS NON-FEE AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

S I R:

In response to the Office Action dated July 2, 2004,  
applicant amends his application as follows:

**ADDITIONAL FEES:**

No additional fees are believed required in  
connection with this response; however, should it be  
determined that a fee is due, authorization is hereby given to  
charge any such fee to our Deposit Account No. 01-0268.